

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Yuuichi MIKATA et al.) Parent Group Art Unit: 2815
)
Application No.: 1.53(b) Divisional of) Parent Examiner: Eckert II, George C.
Application No. 09/459,913 filed)
December 14, 1999)
)
Application No.: To be Assigned)
)
Filed: Herewith)
)
For: RELIABLE SEMICONDUCTOR)
DEVICE AND METHOD OF)
MANUFACTURING THE SAME)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PRELIMINARY AMENDMENT

Prior to the examination of the above-identified divisional application, please
amend this application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 4 of this paper.

Remarks begin on page 8 of this paper.

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